## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:	CONFIRMATION NO.: 4956
Hiromitsu NANBA, et al.	) )
U.S. Serial No.: 10/577,314	) Group Art Unit: 1714
Filed: April 28, 2006	Examiner: Eric W. Golightly
For: SUBSTRATE CLEANING METHOI	D, SUBSTRATE CLEANING APPARATUS AND

## "SUBMISSION" UNDER 37 C.F.R. § 1.114

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This paper accompanies a Request for Continued Examination (RCE) filed concurrently herewith. Both this paper and the RCE address issues raised in the Office Action of May 10, 2010.